

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/523,645	<b>Applicant(s)/Patent under Reexamination</b> KIM, JAE-SOO
	<b>Examiner</b> Michael V. Meller	<b>Art Unit</b> 1655

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner